

**Notice of References Cited**

Application/Control No.

10/509,575

Applicant(s)/Patent Under  
Reexamination  
IIJIMA ET AL.

Examiner

Daniel C. McCracken

Art Unit

1754

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*	B	US-6,420,293	07-2002	Chang et al.	501/95.2
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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